

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) SEC.926D	Application Number 10/687,838		
				Applicant(s) Jung-Hwan Oh et al.			
				Filing Date 20 October 2003	Group Art Unit 2831 2818		
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
dher	A	6,215,187 B1	04/10/2001	Ooto et al.			
dher	B	6,312,986 B1	11/06/2001	Hermes			
FOREIGN PATENT DOCUMENTS							
REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
EXAMINER 				DATE CONSIDERED 07/26/2004			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
<i>dhm</i>	A	5,943,581	08-1999	Lu et al.	/	/	/	
	B	6,271,084	08-2001	Tu et al.	/	/	/	
	C	6,682,984	01-2004	Wu et al.	/	/	/	
	D	6,258,689	07-2001	Bronner et al.	/	/	/	
<i>dhm</i> OCT 12 2004	E	6,586,312	07-2003	Chin et al.	/	/	/	
<b>FOREIGN PATENT DOCUMENTS</b>								
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Group Art Unit  
TBD 2818

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>dhm</i>	A	6,022,772	02/08/2000	Watanabe et al.			
	B	5,545,585	08/13/1996	Wang et al.			
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	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
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<i>ND</i>	M	4-3-259567	11/1991	Japan			<i>No</i>	
<i>Copies</i>	N	4-5-6974	1/1993	Japan			<i>Translation</i>	
<i>provided</i>	O	2001-57413	02/27/2001	Japan			<i>provided.</i>	

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<i>dhm</i>	P	Combined Search and Examination Report Under Sections 17 and 18(3) from the UK Patent Office dated 9 July 2003.
<i>NO copy provided</i>	Q	<del>Fukuzumi et al., Liner-Supported Cylinder (LSC) Technology to realize Ru/Ta2O5/Ru Capacitor for Future DRAMs, 2000, IEEE, IEDM 00, pp. 793-96.</del>

EXAMINER

*Thao*

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